

Reg.No.																			
---------	--	--	--	--	--	--	--	--	--	--	--	--	--	--	--	--	--	--	--



MANIPAL INSTITUTE OF TECHNOLOGY
Manipal University, Manipal – 576 104



**VII SEM. B.Tech. (MECHANICAL/ I & P ENGG.) END SEMESTER
EXAMINATIONS NOV/DEC 2015**

**SUBJECT: NANOTECHNOLOGY (MME 451)
REVISED CREDIT SYSTEM**

Time: 3 Hours.

MAX.MARKS: 50

Instructions to Candidates:

- ❖ Answer **ANY FIVE FULL** questions.

- 1A** What are secondary electrons and backscattered electrons? What are their applications in Scanning Electron Microscopy? (3)
- 1B** What is an elastic hinge guide system? Draw the sketches of linear, torsional and combined motions. (5)
- 1C** What is photolithography? Explain how its resolution can be reduced? (2)
- 2A** Explain the mechanism of material removal in atomic bit processing in no defect or subatomic range, using Modified Morse plot of interatomic spacing Versus free potential energy. (3)
- 2B** With sketches explain the constant height mode and constant current mode of operation of a Scanning Tunneling Microscopy (STM). (4)
- 2C** With necessary sketches explain the fabrication process of holographic gratings. (3)
- 3A** With necessary diagram explain directional ion beam processing. (5)
- 3B** With neat and labelled sketches explain the various configurations of hydrostatic slides used for nano-positioning. (5)
- 4A** With necessary sketch briefly explain the Molecular beam surface processing or Molecular beam epitaxy. (2)

- 4B** Why Nano-grinding is preferred over nano- turning in machining of hard and brittle materials? With a neat sketch explain Electrolytic in-process dressing of Metal bonded diamond wheels. **(4)**
- 4C** With necessary sketches explain Nano-Glassy servo system. **(4)**
- 5A** Explain how Nanotechnology can be used for sustainable development in developing countries? **(5)**
- 5B** With block diagram explain the servo control system for tool positioning of nanometer system. **(5)**
- 6A** With necessary sketches explain the working principle of High Precision Optical Surface Sensor (HIPOSS). **(3)**
- 6B** With necessary sketches explain the manufacturing process of ultra-precision balls for roller bearings. **(4)**
- 6C** With a neat and labelled sketch explain the working of Laser interferometer which uses Heterodyne method with a two-wavelength Zeeman laser. **(3)**